

Vacuum Electron Staining Apparatus

For safe and reproducible electron staining on electron microscopy samples



Filgen, Inc.

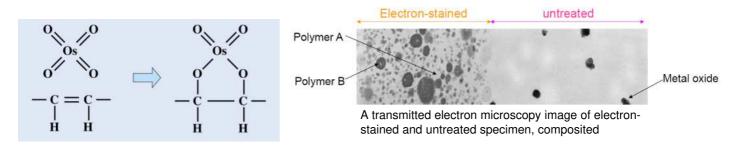
Overview

High reproducibility and safely operations

Principles

What is electron staining?

Electron staining is a method for enhancement image contrast of electron microscopy specimens which are composed with light element (eg. polymer materials, biological specimens etc.), by binding heavy metals. For polymer specimens, osmium tetroxide (OsO₄) and ruthenium tetroxide (RuO₄) are often used



What is "vacuum" electron staining?

Conventional electron staining is performed under atmospheric pressure by exposing specimen to gaseous OsO_4 or RuO_4 or immerses it to those solutions. However, it often causes overstaining or lack of reproducibility. Also, there is a risk for operators to expose to those staining agents which are highly poisonous.

In contrast, our patented technology, vacuum electron staining enables more precise and safer staining by performing staining in vacuum. Staining time and gas pressure (that is, density of staining agent) in reaction chamber as well as timing of gas introducing and exhausting are automatically controlled.

Benefits

Safe operation



Risk for exposure to toxic staining agent with high sublimability. Drafter is required.

No chance to exposure to toxic substance, with closed system and multiple safety measure.

Effective for hygroscopic specimens

staining is performed by dry gas generated from OsO4 crystal (not aqueous solution)

Rapid and deeply staining Less surface contamination For determining optimal condition

Different staining time or density of agent can be set *only on 4-chamber model.

High reproducibility



Unable to control density of staining agent, over staining occurs by remained gas.



Automatic and precise control for staining time and density of agent. Eliminates over staining.

Stain without atmospheric exposure

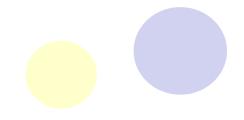




Air isolation chamber, middle, top-front view

Air isolation chamber, mini and main unit





Applications

For SEM/TEM samples

- Enhancement image contrast for polymer specimens
- Fixation for polymer specimens before ultramicrotome sectioning
- Reduction of outgassing from specimens at in electron microscope chamber

Product appearance

Model# VSC4TWDH

For SEM samples

*only on model# VSC4TWDH

- Elimination or reduction of charging effects on nonconductive specimens
- Embrittilement of specimens before fracturing

Model# VSC1R1H

- <image>
 - High-resolution interactive touch panel controller

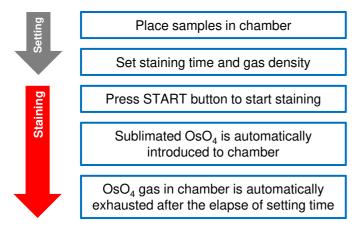
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	слоя слоя слоя слоя СМ1 СН2 СН3 жерн	VACUUM GAUGE (H1)
		Off Off </th
Easy and institutive operation by step-by-step visual guide	Save usage of staining agent thanks to the function which activate/deactivate chambers individually	Easy to confirm staining settings anytime from slide-in tab

* Images are from Japanese model. English version is available.

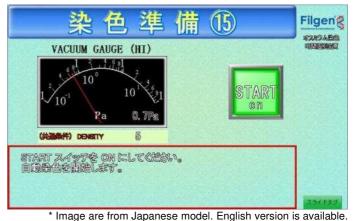
Details

Operation flow

Whole process is completed by just press START button after setting of time and gas density.



With the model# VSC4TWDH, all operation can be made easily by step-by-step guide on thouchpanel screen.



Safety measures

Interlocking system with reaction chamber

- i. unable to open the chamber unless OsO4 is exhausted
- ii. unable to introduce OsO4 when the chamber open

Osmium absorption filter

Not require any ventilation systems. Osmium concentration in exhaust gas is confirmed as safe level or lower by a third-party organization

Multiple safety features on Os reservoir

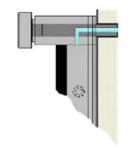
- i. Gas-tight and robust design
- ii. Gas port integrated locking pin (see below)
- iii. Built-in ampoule cutter.
- iv. Detachable and capable to store in freezer

Failsafe system against power cut

No chance to leak OsO4 gas when power is cut and recovered

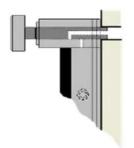
Mechanisms of OsO4 reservoir

The gas port integrated locking pin of reservoir can simultaneously control status for reservoir locking and gas supply in safe.



Full-opened (during operation) Reservoir: locked (undetachable) by manually inserted locking pin of reservoir

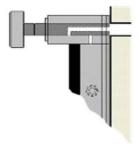
OsO₄ gas: can be introduced (depends on solenoid status)



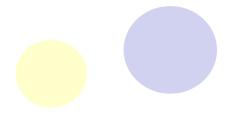
Half-closed (before reservoir detach)

Reservoir: locked (undetachable) by manually inserted locking pin of reservoir

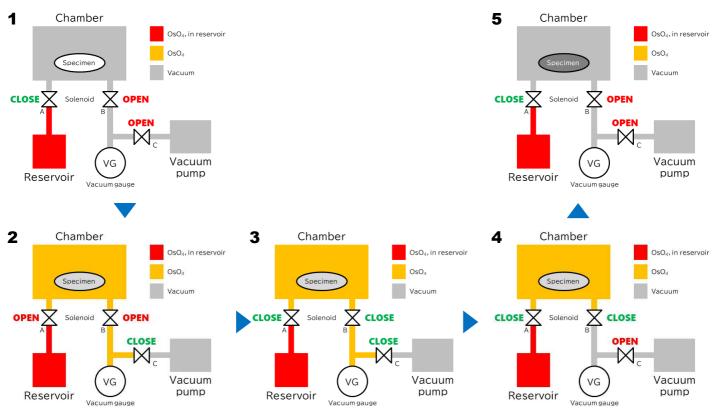
 OsO_4 gas: blocked *residual gas in the inlet pipe must be evacuated at this step



Full-closed (after operation) Reservoir: unlocked (detachable) OsO₄ gas: blocked



Process of vacuum electron staining



1. Before processing

 OsO_4 is not introduced to chamber

Chamber is in vacuum

2. Gas introduction

Solenoid A is opened, and C is closed, just after start of the process Sublimated OsO_4 is introduced in chamber gradually

3. Gas density adjustment

All solenoids are closed after OsO4 density reaches to set level

4. Staining

Now staining is running in closed chamber

Solenoid C is opened and OsO4 in piping is evacuated

5. Post staining

After the elapse of set staining time, solenoid B is opened and all residual gas is evacuated

Comparison: Vacuum electron staining vs. conventional

	Vacuum electron staining	Conventional method
1. Before processing	Inside of specimen as well as chamber are maintained vacuum	Under normal pressure
2. Gas introduction	Staining gas is immediately permeate to inside of specimen by high difference of pressure.	Longer time is necessary to permeate staining gas to inside of specimen.
3. Gas density adjustment	Gas density is automatically adjusted to set level (1-10 level)	Difficult to precise control of gas density
4. Staining	Density of staining gas is maintained by gas-tight chamber with solenoids	
5. Post staining	Remaining gas inside specimen is sucked out by negative pressure	Staining gas is remained inside of specimen.

Products

Specifications

Model#		VSC4TWDH	VSC1R1H
Interface		Interactive touch panel control	Mechanical switches, knobs,
			digital timer/temp controller,
			and analog vacuum meters
Staining agent		OsO ₄ (crystals) in glass ampoule	
Density of staining agent		1-10 degree	
Staining time	Number	1 min to 17hr 4	0.0-999.9 min
Reaction		•	1
chamber	Inner size	86(ID) x 50(H) mm	
	Observation window	<pre>✓ (upper side)</pre>	
Heating system		✓ (RT to 70 degC)	
Reservoir	Number		
	Detachable		
	Built-in ampoule	✓ (International Sector)	
	cutter Observation window		
	Storage temp. *after detaching	-20 degC to 4 degC	
Gas introducing		Automated control with vacuum gauge, solenoids, and vacuum pump	
Gas introducing/exhausting system Safety measure			
		 Fully automated control system with interlocking Desidual ass than write 	
		- Residual gas trap unit	
Ci-a		- Gas tight reservoir with built-in ampoule cutter	
Size		610(W) x 445(D) x 510(H) mm	450(W) x 425(D) x 445(H) mm
Weight	Type	Approx. 50 kg Approx. 30 kg	
Vacuum pump Type Actual pumping speed		Two-stage oil rotary vacuum pump 200 L @50Hz	
	Size	<u> </u>	
		170(W) x 515.5(L) x 249.5 (H)	
Accessories -		31 kg - Gas-tight OsO, reservoir 1 nc	
		 Gas-tight OsO₄ reservoir, 1 pc. Vacuum pump, 1 unit 	
		- Vacuum pump, I unit - Residual gas trap unit, 1 unit	
		- Connecting parts	
		- Cleaning kit	
		 Cleaning Kit Instruction manual (English version, printed) 	
		- instruction manual (English version, printed)	

Accessories

Air isolation chamber



TEM Grid Holder



Holds up to 8 pcs of TEM grid. Stainless steel made

Enables electron staining under anaerobic condition. Suitable for materials which have high activity or reactivity with oxygen or moisture (eg, Negative electrode materials of Li-ion battery). 2 different sizes are available

Osmium reservoir



Detachable, equipped with safety features.

OsO₄ ampoules



Transportation Container

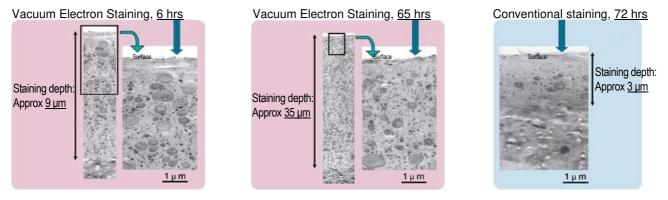


Enable safer transportation for OsO4 reservoir. Stainless steel made.



Technical data #1

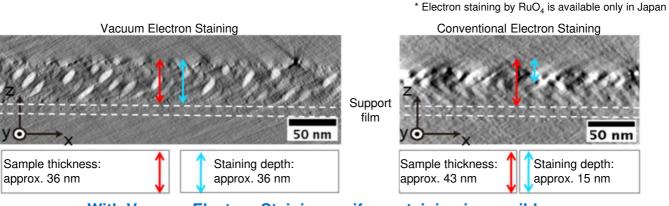
TEM images of cross sectioned ABS, OsO₄ stained



With Vacuum Electron Staining, deeper staining with shorter running time is possible.

Technical data #2

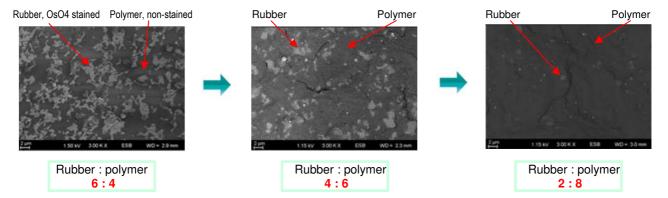
Reconstructed 3D images by electron tomography, RuO₄ stained



With Vacuum Electron Staining, uniform staining is possible.

Technical data #3

SEM images of Rubber-dispersed polymer with different blend ratio, OsO₄ stained



With Vacuum Electron Staining, dispersion of polymers can be evaluated.



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